

# Processing of Nanocomposites

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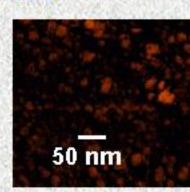


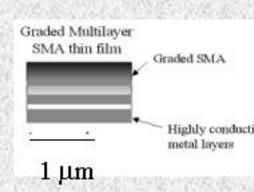


### WHAT IS A NANOCOMPOSITE?

- Materials featuring:
  - Nanoparticle, nanofiber, or nanotube reinforcement in a matrix material
  - 2. Nanometer thick layers of different material systems or properties

Aluminum nanoparticles in epoxy





Graded Multilayer Thin Film

### MOTIVATION AND NEEDS FOR **NANOCOMPOSITES**

#### MOTIVATION

Develop nanocomposites with controlled microstructures using twin-screw extrusion (TSE) processing technology and characterize their mmicrostructure and echanical behavior using microscopy techniques with Digital Image Correlation for developing models of their physical behavior

### NEEDS

- Processing Models for Predicting Effects of TSE Operating Conditions on the Microstructural Evolution
- **Multiscale Characterization of Mechanical Behavior**
- **Property and Performance Models**

## ADVANTAGES OF TSE PROCESSED NANOCOMPOSITES

- Biologically Inspired Hierarchical Composites with Enhanced Mechanical Strength and Toughness
- Increased Dispersion of Aluminum Nanoparticles in Propellants for Improved Burn Rate Performance
- Functionally Graded Materials with Optimized System Performance
- Oriented CNT Composites with Novel Anisotropic Physical Properties

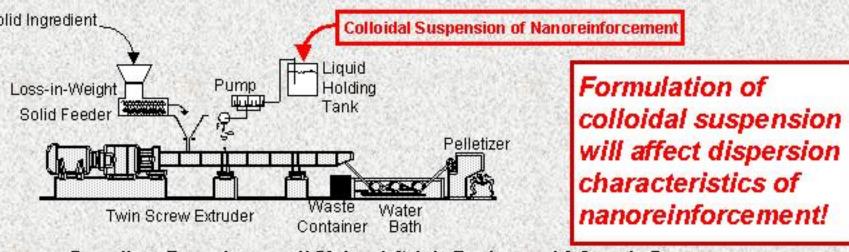
### RESEARCH APPROACH

- Processing
  - Preprocessing of nanoparticles in colloidal suspensions to minimize agglomeration
  - Addition of nanoparticles at different locations in extruder
  - Design of extrusion head to control orientation of nanofibers and nanotubes

#### Characterization

- Advanced microstructural characterization techniques such as Atomic Force Microscopy (AFM)
- 2. Multiscale mechanical characterization techniques such as Digital Image Correlation and Hardness Testing

### TSE PROCESSING OF **NANOCOMPOSITES**



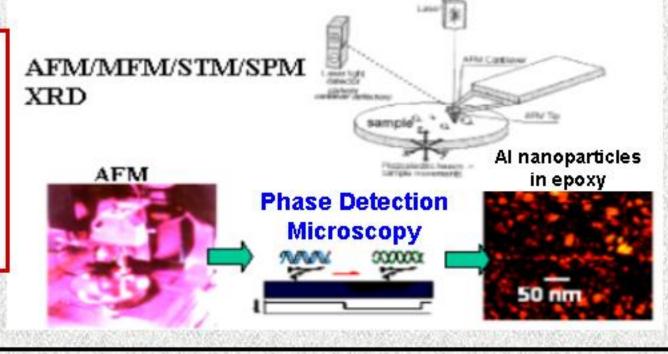
- Propellant Formulation will Utilize 3 Solids Feeders and 2 Liquids Pumps
- 28 mm Lab-Scale Extruder UMD/College Park
- 40 mm Pilot-Scale Extruder NSWC/IHDIV

### SPUTTER DEPOSITION OF NANOSTRUCTURED FILMS

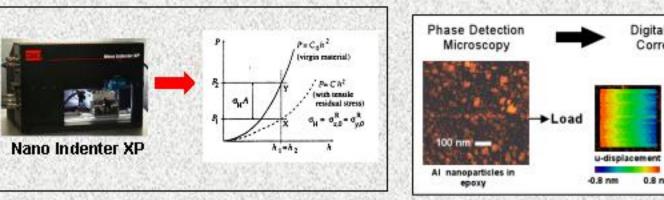


### MICROSTRUCTURAL CHARACTERIZATION

Can characterize microstructure using microscopy techniques, like **Atomic Force** Microscopy (AFM), with nanoscale resolution!



### MECHANICAL CHARACTERIZATION



**Property and Stress** Characterization using **Hardness Testing** 

Deformation Characterization using **Digital Image Correlation** 

### SUMMARY

- TSE processing of nanocomposites with controlled microstructures (hierachical, dispersed, graded, oriented)
- New TSE processing models for nanocomposites based on convoluting RVDs with operating conditions for predicting microstructural evolution
- Microstructural characterization using AFM techniques
- Multiscale mechanical characterization using Hardness **Testing and Digital Image Correlation**